

9/2004 09/885,451 L18

FAST - Default EAST WorkSpace [FAST.PANEL.LANDSCAPE] [web]

Drafts
BRS:
Pending
Active

L1: (4) ("6569299") or ("6521162") or ("6077419") or ("6332963")
L2: (1) ("20030159936"). FN.
L3: (1) ("2002002363"). FN.
L4: (124390) anneals
L5: (1) 13 and 14
L6: (1201815) current
L7: (1) 13 and 16
L8: (5441) low adj K
L9: (520) 18 same 14
L10: (47428) electroplating or electrodeposits
L11: (4110) electrochems near2 deposits
L12: (49760) 110 or 111
L13: (412817) copper or Cu
L14: (17990) 112 same 113
L15: (162) 19 and 114
L16: (418) 114 and 18 and 14
L17: (467451) semiconductor or semiconductors or wafer or wafer
L18: (416) 116 and 117

Failed
Saved
Saved

Document ID	Issue/Date	Pages	Title	Current OR	Current (Ref. Retrieval)	CI	Inventor	U	S	C	P	FI	SI	PI	PR
1	US 20040180541	20040916	12	Soft metal conductor and method of making	438/675	438/653;	Josh, Rajiv Vasant	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
2	US 20040180532	20040916	8	Method for forming a self-passivated copper	438/626	438/656;	Shue, Shau-Yin et al.	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
3	US 20040178060	20040916	18	Apparatus and method for depositing and planarizing	204/232	438/633	Kavkin, Mike et al.	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
4	US 20040175929	20040909	14	Method of improving interlayer adhesion	438/628		Schmitt, Francimar Campaña et al.	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
5	US 20040170753	20040902	13	Electrochemical mechanical processing using low	427/58	427/299	Basol, Bulent M.	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
6	US 20040169255	20040902	24	Semiconductor device and method of manufacturing same	257/532		Kiyotoshi, Masahiro	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
7	US 20040166783	20040826	24	Polishing apparatus and method	451/41		Kimura, Norio et al.	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
8	US 20040166693	20040826	20	Sputtering target compositions, and methods of	438/785	204/192, 1;	Li, Jianxing et al.	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
9	US 20040166665	20040826	18	Method of decreasing the K value in SiOC layer	438/622	438/638;	Gaillard, Frederic et al.	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
10	US 20040164420	20040826	20	Sputtering target compositions, and methods of	257/763	257/762;	Li, Jianxing et al.	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
11	US 20040159951	20040819	46	Semiconductor device and manufacturing method of	257/762	438/687	Toyoda, Hiroshi et al.	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
12	US 20040157442	20040812	14	ROBUST VIA STRUCTURE AND METHOD	438/687		Cowley, Andy et al.	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>

Search
BRS
USPAT:US-66PUB
Default operator: DR

116 and 117

Print
Print all items